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CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the below date:

Data Fabruary 27, 2007

Name: Jason M. Wejnert, Reg. No. 55.722 Signature:

An additional filing fee has been calculated as shown below:

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# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of:

Hastwell et al.

Serial No.: 10/562,369

Filing Date: December 22, 2005

For: MICRO AND NANO SCALE

FABRICATION AND MANUFACTURE BY SPATIALLY SELECTIVE DEPOSITION

Our Case No. 13004/4 (21066US)

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 Examiner:

Not Yet Assigned

Group Art Unit: Not Yet Assigned

TRANSMITTAL

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Sir:

Date

M	Preliminary Report on Patentability and International Search Report for the corresponding PCT Application No. PCT/AU2004/000864.
$\boxtimes$	Return Receipt Postcard.
Fee ca	alculation:
	No additional fee is required.
$\boxtimes$	Small Entity.
	An extension fee in an amount of \$ for amonth extension of time under 37 C.F.R. § 1.136(a).
	A petition or processing fee in an amount of \$ under 37 C.F.R. § 1.17().

,					Sma	Small Entity		Not a S	mall Entity
	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra	Rate	Add'l Fee	or	Rate	Add'l Fee
Total		Minus		0	X \$25=			x \$50=	
Indep.		Minus		0	X 100=			x \$200=	
First Pre	esentation of Multiple D	ep. Claim	1		+\$180=			+ \$360=	
					Total	\$		Total	

		Total	\$	Total		
	A check in the amount of \$ to cover the filing fee is enclosed.	osed.				
	Please charge Deposit Account No. 23-1925 in the amount of for this purpose.	f\$ .	A copy of	this Transmitt	al is enclos	ed
	Payment by credit card in the amount of \$ (Form PTO-	2038 is a	ttached).			
	The Director is hereby authorized to charge payment of any a and any patent application processing fees under 37 CFR extension fee required to ensure that this paper is timely Account No. 23-1925.	§ 1.17 a	ssociated v	vith this pape	r (including	any
		tfully subi				
Febri	uary 27, 2007	am W	bret			

Jason M. Wejner∜(Reg. No. 55,722)

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Alexandria, Virginia 22313-1450

on February 27, 2007

Date of Deposit

Jason M. Wejnert, Reg. No. 55,722

Name of applicant, assignee or Registered Representative

Signature

February 27, 2007

Date of Signature

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Examiner: Not Yet Assigned

Group Art Unit: Not Yet Assigned

# INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(b), Applicants hereby cite the following references:

# U.S. AND FOREIGN REFERENCES

Patent/ Publication No.	Date of Issue/Publication	Patentee/Applicant/Country
US 2004/0055892 A1	03/25/2004	Oh et al.
WO 03/062456 A1	07/31/2003	PCT
JP 04-086602	03/19/1992	Japan

#### **OTHER ART**

Steward et al., "NanoXerography: The Use of Electrostatic Forces to Pattern Nanoparticles," Proceedings of the 2003 NSF Design, Service and Manufacturing Grantees and Research Conference, pp. 1-7.

For the Examiner's convenience, Applicant is enclosing Form PTO-1449 (one sheet) and copies of cited references A2-A4. The relevance of the non-English references is noted in the enclosed International Preliminary Report on Patentability and International Search Report for the corresponding PCT Application

No. PCT/AU2004/000864, attached English Abstracts and/or corresponding U.S.

Patents. Applicants respectfully request the Examiner's consideration of the above references and entry thereof into the record of this application.

By submitting this Statement, Applicants are attempting to fully comply with the duty of candor and good faith mandated by 37 C.F.R. §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 C.F.R. §1.56(a).

Applicants have calculated no fee to be due in connection with the filing of this Statement. However, the Director is authorized to charge any fee deficiency associated with the filing of this Statement to a deposit account, as authorized in the Transmittal accompanying this Statement.

Respectfully submitted,

February 27, 2007

Jason M. Wejnert Reg. No. 55,722

Attorney for Applicants

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FORM PTO-1449	SERIAL NO.	CASE NO.
The state of the s	10/562,369	13004/4 (21960US)
LIST OF PATENTS AND PUBLICATIONS FOR	FILING DATE	GROUP ART UNIT
APPLICANT'S INFORMATION DISCLOSURE STATEMENT	December 22, 2005	Not Yet Assigned
	APPLICANTS: HASTWELL et a	al.

### REFERENCE DESIGNATION

### **U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER Number-Kind Code (if known)	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
	A1	US 2004/0055892 A1	03/25/2004	Oh et al.		

#### **FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER Number-Kind Code (if known)	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO
	A2	WO 03/062456 A1	07/31/2003	Japan		Corresponding U.S. patent
	А3	JP 04-086602	03/19/1992	Japan		Abstract only

EXAMINER INITIAL		OTHER ART — NON PATENT LITERATURE DOCUMENTS de name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, osium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.
	A4	Steward et al., "NanoXerography: The Use of Electrostatic Forces to Pattern Nanoparticles," Proceedings of the 2003 NSF Design, Service and Manufacturing Grantees and Research Conference, pp. 1-7.

EXAMINER	DATE CONSIDERED	
L/O WINTER	DATE CONCIDENCE	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.